

SEP 20 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Quevedo-Lopez et al. Art Unit: 2822
Serial No.: 10/726,987 Examiner: Thomas, T.
Filing Date: 12/03/2003 Docket No.: TI-36376
Customer No.: 23494 Conf. No.: 5051
Title: TOP SURFACE ROUGHNESS REDUCTION OF HIGH-k DIELECTRIC
MATERIALS USING PLASMA BASED PROCESSES

REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by
facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on
the date shown below.


Jacqueline J. Garner, Reg. No. 36,144

September 20, 2005
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner
for an extension of the shortened statutory period for response in the above-identified
Application.

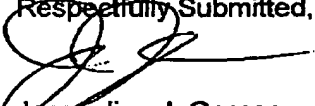
The fee for this extension is indicated below:

- ☐ One Month (\$120)
☒ Two Months (\$450)
☐ Three Months (\$1,020)
☐ Four Months (\$1,590)

Please charge the fee to deposit account no. 20-0668. Any further necessary
extension of time is hereby requested. Charge any and all fees to deposit account no. 20-
0668.

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Respectfully Submitted,


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